

mirror M_0 is placed between the single-pass lens group A_1 and the double-pass lens group A_2 .

The turning mirror M_0 permits the reticle R and the wafer W to be in parallel planes. As shown in FIG. 5, the reticle R and the wafer W are along the same optical axis [312] 310.--

REMARKS

INTRODUCTION:

In accordance with the foregoing, the specification has been amended to improve form in the manner prescribed by 37 CFR §1.173. No new matter is being presented, and approval and entry of the foregoing amendment is respectfully requested.

Claims 1-58 are pending and have been indicated as containing allowable subject matter.

SUBMISSION OF ORIGINAL PATENT AS PER 37 CFR 1.178:

Please find enclosed the original patent in compliance with 37 C.F.R. §1.178. As such, it is respectfully submitted that the applicant has complied with the requirements of 37 CFR §1.178.

CONCLUSION:

In accordance with the foregoing, it is respectfully submitted that all outstanding objections and rejections have been overcome and/or rendered moot. And further, it is respectfully submitted that all pending claims patentably distinguish over the prior art. Thus, there being no further outstanding objections or rejections, the application is submitted as being in condition for allowance which action is earnestly solicited.

SERIAL NO. 09/659,375

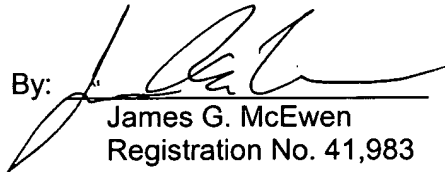
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If the Examiner has any remaining issues to be addressed, it is believed that prosecution can be expedited by the Examiner contacting the undersigned attorney for a telephone interview to discuss resolution of such issues.

If there are any additional fees associated with the filing of this Amendment, please charge the same to our Deposit Account No. 19-3935.

Respectfully submitted,

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